

INFORMATION DISCLOSURE CITATION IN AN OIPE APPLICATION				ATTY. DOCKET NO. <b>1268-093A</b>		SERIAL NO. Not Yet Assigned		
				APPLICANT Moshe FINAROV				
(PTO-1449) FEB 2 6 2001 (PTO-1449)				filing date July 26, 2000		GROUP		
PATENT DOCUMENTS								
EXAMINER'S INITIALS	PATENT NO.	DATE	1	IAME	CLASS	SUBCLASS	FIL DA	
BE	5,604,344	2/1997	Finarov					
DBE	5,682,242	10/1997	Eylon			0		
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FOREIGN PATENT DOCUMENTS  EXAMINER'S Translation								
INITIALS	PATENT NO.	DATE	CO	UNTRY	CLASS	SUBCLASS	Yes	No
186	95/11446	04/27/95	W.I.P.O.					;
DISE	9-50959	02/18/97	JAPAN					
THE	0 412 728	02/13/91	E.P.O.		-			
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OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
DEE	Dishon et al., "Monitoring Choices of CMP Planarization Processes", pp. 1-10, Feb. 1997.							
DEE	English Language Abstract of JP 9-50959.							
DATE CONSIDERED 3/5/03								
2000				7.0/05				

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.